

UNITED STATES PATENT AND TRADEMARK OFFICE  
**CERTIFICATE OF CORRECTION**

PATENT NO. : 7,372,202 B2  
APPLICATION NO. : 10/829666  
DATED : May 13, 2008  
INVENTOR(S) : Eden et al.

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Title page, item [56] References Cited, OTHER PUBLICATIONS (Continued):

Page 2, delete "1143-1147" and insert -- 1142-47 -- therefor.

Column 2, line 17, after "BRIEF DESCRIPTION OF THE DRAWINGS," please insert the following paragraph.

-- The patent or application file contains one drawing executed in color. Copies of this patent or patent application publication with color drawing(s) will be provided by the Office upon request and payment of the necessary fee. --

Column 3, replace lines 20-35 with the following paragraph.

-- More generally, a phase-locked microdischarge array of the invention is an important new device that can form a substitute for compact semiconductor lasers or other optical sources in many applications, such as illumination for microscopy. Preferred embodiment arrays of the invention act as a single source that is capable of producing a tightly focused beam, the energy of microdischarges in the array combining to produce a significantly more powerful beam than is available from a single microdischarge device. An array of the invention is also highly compact. For example, a substrate of the invention might be less than one mm thick and have a diameter of only a few millimeters, for example <3mm. Preferred Fresnel array embodiments of the invention effectively produce a combined light source and lens. --

Signed and Sealed this

Sixteenth Day of September, 2008



JON W. DUDAS  
*Director of the United States Patent and Trademark Office*